

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S29	2	("6361647" "6497784").pn.	US-PGPUB; USPAT	OR	OFF	2008/12/17 16:10
S28	1	"6489249".pn.	USPAT	OR	OFF	2008/08/12 13:02
S27	0	"6489249".pn.	US-PGPUB	OR	OFF	2008/08/12 13:02
S26	1	"10536621"	US-PGPUB	OR	OFF	2008/08/12 12:05
S25	1066	(polish\$3 planari\$5 CMP) and (light optical) with (transmission transmitting)	EPO; JPO; DERWENT	OR	OFF	2008/08/12 12:03
S24	3043	S22 S23	EPO; JPO; DERWENT	OR	OFF	2008/08/12 12:02
S23	2300	(polish\$3 planari\$5 CMP) and (transmission)	EPO; JPO; DERWENT	OR	OFF	2008/08/12 12:02
S22	894	(polish\$3 planari\$5 CMP) and (transmitting)	EPO; JPO; DERWENT	OR	OFF	2008/08/12 12:02
S21	405	Nakamori-masahiko. in. shimomura-tetsuo. in. "yamada-takatoshi- in." ogawa-kazuyuki. in. kazuno-atsushi.in. watanabe-mimhiro.in.	EPO; JPO; DERWENT	OR	OFF	2008/08/12 12:02
S20	11	(Nakamori-masahiko. in. shimomura-tetsuo. in. "yamada-takatoshi- in." ogawa-kazuyuki. in. kazuno-atsushi.in. watanabe-mimhiro. in.) and "transmitting region"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/08/12 12:00
S19	0	subaperature with (CMP polish\$3 planarization)	US-PGPUB; USPAT	OR	OFF	2008/08/12 09:46
S18	131	S16 and (transmission transmitting)	US-PGPUB; USPAT	OR	OFF	2008/08/11 15:19
S17	1207314	S16 and transmission	US-PGPUB; USPAT	OR	OFF	2008/08/11 15:18

S16	840	pad with (smaller diameter) with (wafer semiconductor) same (CMP polish\$3 planari \$6)	US-PGPUB; USPAT	OR	OFF	2008/08/11 15:18
S15	1183	pad with (smaller diameter) with (wafer semiconductor) and (CMP polish\$3 planari \$6)	US-PGPUB; USPAT	OR	OFF	2008/08/11 15:18
S14	502	pad with (smaller diamter) with (wafer semiconductor) and (CMP polish\$3 planari \$6)	US-PGPUB; USPAT	OR	OFF	2008/08/11 15:18
S13	265	macarthur-s\$.xa. macarthur-s\$.xp.	US-PGPUB; USPAT	OR	OFF	2008/08/11 15:07

12/17/08 9:17:32 PM

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